

3521 US. PTO
02/01/2002
10062790

U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10062790	FILING DATE 02/01/2002	CLASS 525	SUBCLASS 1	GAU 152 1711	EXAMINER A. J. JON
----------------------	---------------------------	--------------	---------------	--------------------	-----------------------

**APPLICANTS: Deshpande Shreeram;

**CONTINUING DATA VERIFIED:

BEST AVAILABLE COPY

** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO 31937
35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		
Verified and Acknowledged Examiners's initials		
TITLE : Organic anti-reflective coating compositions for advanced microlithography		
U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)		

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for 0.0
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Applicant's Examiner	
WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.				

FILED WITH: ☐ DISK (CRF) ☐ CD-ROM
(Attached in pocket on right inside flap)